



Docket No.: 1794-0141P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yoshinobu AOYAGI et al.

Application No.: 09/941,612

Confirmation No.: 6758

Filed: August 30, 2001

Art Unit: 1792

For: IMPURITY DOPING METHOD FOR
SEMICONDUCTOR AS WELL AS SYSTEM
THEREFOR AND SEMICONDUCTOR
MATERIALS PREPARED THEREBY

Examiner: M. J. Song

OK to
enter
C. Queen
4/15/07

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated August 2, 2007, the due date for response having been petitioned to be extended three (3) months to February 2, 2008, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amended Claims Set; and

Remarks.